

10/594061

IAP01 Rec'd PCT/PTO 25 SEP 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yuichi SHIBAZAKI

New U.S. Patent Application

Filed: September 25, 2006

Docket No.: 129526

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND DEVICE
MANUFACTURING METHOD

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Remarks.